



Jon

# AMENDMENT TRANSMITTAL LETTER

Docket No.  
SON-2563

Application No.  
10/501,155-Conf. #5207

Filing Date  
July 13, 2004

Examiner  
N. R. Blan

Art Unit  
1792

Applicant(s): Koichiro Shoji

Invention: SURFACE TREATMENT METHOD, SEMICONDUCTOR DEVICE, METHOD OF  
FABRICATION SEMICONDUCTOR DEVICE AND TREATMENT APPARATUS

## TO THE COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	28	- 48 =	0	x 52.00	0.00
Independent Claims	3	- 16 =	0	x 220.00	0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					0.00

☒ Large Entity

☐ Small Entity

☒ No additional fee is required for this amendment.

☐ Please charge Deposit Account No. 18-0013 in the amount of \$ \_\_\_\_\_.

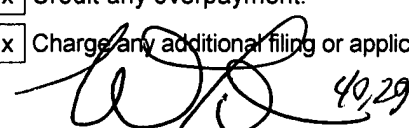
☐ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.

☐ Payment by credit card. Form PTO-2038 is attached.

☒ The Director is hereby authorized to charge and credit Deposit Account No. 18-0013  
as described below. A duplicate copy of this sheet is enclosed.

☒ Credit any overpayment.

☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

  
Ronald P. Kananen/Christopher M. Tobin  
Attorney/Agent Reg. No.: 24,104/40,290

Dated: April 17, 2009

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